Docket No. 263788US2PCT

IN RE APPLICATION OF: Keisuke KAWAMURA, et al.

SERIAL NO: 10/519,475

FILED: December 28, 2004

FOR: APPARATUS FOR PLASMA PROCESSING, METHOD OF PROCESSING SUBSTRATE THEREWITH,

APPARATUS FOR PLASMA-ENHANCED CHEMICAL VAPOR DEPOSITION, AND METHOD FOR FILM

FORMATION THEREWITH

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Transmitted herewith is an amendment in the above-identified application.

- ☐ No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- Additional documents filed herewith: Request for Extension of Time (1 month)

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS		RATE		CALCULATIONS
TOTAL	12	MINUS	20	0	х	\$50	=	\$0.00
INDEPENDENT	4	MINUS	4	0	х	\$210	=	\$0.00
APPLICATION SIZE		MINUS	100	0 (each addtl. 50 sheets)	x	\$260	=	\$0.00
	☐ MULTIPLE DEPENDENT CLAIMS + \$370 =					\$0.00		
			TOTAL OF ABOVE CALCULATIONS					\$0.00
	☐ Reduction by 50% for filing by Small Entity					\$0.00		
						TOT	AL	\$0.00

- ☐ A check in the amount of **§0.00** is attached.
- Online credit card payment is being made to cover the fees in the amount of \$120.00
- Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030.
- If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030.

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